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*<sup>2</sup> Wuhan National Lab for Optoelectronics, Huazhong University of Science and Technology, CHINA*  
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*<sup>1</sup>Department of Mechanical Engineering, Chang Gung University, TAIWAN*  
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*<sup>1</sup>Institute of Microelectronics, Tsinghua University, CHINA*  
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*<sup>1</sup>School of Optoelectronic Science and Engineering, Huazhong University of Science and Technology, CHINA*  
*<sup>2</sup>MOEMS Division, Wuhan National Lab for Optoelectronics, Huazhong University of Science & Technology, CHINA*  
*<sup>3</sup>Institute of Microsystems, State Key Lab of Digital Manufacturing Equipment & Technology, School of Mechanical Science and Engineering, Huazhong University of Science & Technology, CHINA*  
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*<sup>1</sup>Research and Development Center for Microsystem Reliability Department of Mechanical Engineering, Chung Yuan Christian University, TAIWAN*  
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*<sup>1</sup>Institute of Microengineering and Nanoelectronics, Universiti Kebangsaan Malaysia, MALAYSIA.*  
*<sup>2</sup>School of Mechanical Engineering, Universiti Sains Malaysia, MALAYSIA.*  
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*<sup>1</sup>Tsinghua University, CHINA*  
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*<sup>1</sup>State Key Laboratory of Solid State Lighting (Changzhou Base), CHINA*  
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